

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. MI22-1531	SERIAL NO. 09/755,673	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Leonard Forbes, et al.		
APR 03 2003 U.S. TRADEMARK OFFICE					FILING DATE January 5, 2001	GROUP 2823	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
K.N.	AA	6,246,076	06/01	Lipkin, et al.			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AB						Yes No
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
K.N.	AC	S. Ogawa, et al., Silicon-Aluminum Oxynitride Composite Films Deposited by Reactive Ion Beam Sputtering.				IEEE 1999, pp. 775-778.	
	AD						
	AE						
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EXAMINER <i>Khrennugyan</i>			DATE CONSIDERED 12/24/03				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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